

12-31-01

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Atty. Docket No. AMAT/5998/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application  
Assistant Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Re: Inventor(s): Alain Duboust; Lihong Sun; Feng Liu; Yuchun Wang; Yan Wang; Siew Neo; Liang-Yuh Chen

Title: ELECTROLYTE COMPOSITION AND TREATMENT FOR ELECTROLYTIC CHEMICAL MECHANICAL POLISHING

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 21 pages.
- ☒ Drawings totaling 1 pages,      Formal ☒ Informal.
- Executed Declaration and Power of Attorney.
- Information Disclosure Statement w/ Form 1449 and References.
- Assignment of the invention to **Applied Materials, Inc.**
- Assignment Recordation Cover Sheet

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	43	-20=	23	x \$18.00	\$414.00
Independent Claims	8	-3=	5	x \$84.00	\$420.00
Basic Filing Fee				\$740.00	\$740.00
<b>TOTAL FEES</b>					<b>\$1574.00</b>

     The Commissioner is hereby authorized to charge to Deposit Account No.                     

     The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No.                     . A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to: **PATENT COUNSEL  
APPLIED MATERIALS, INC.  
Legal Affairs Department  
P.O.BOX 450A  
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231

Express Mail Receipt No.: EL 684620753US  
Date of Deposit: 12/21/01  
Signature: Robb D. Edmonds

Respectfully submitted,

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10/032275  
12/21/01

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12/21/01